

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Shen et al.	Group Art Unit: 1746
Application No: 09/507.629	Examiner: Allan W. Olsen
Confirmation No: 7912	Attorney Docket No:
Filed: February 18, 2000	001945 USA P03/ETCH/SILICON/JB
Title: SELF-CLEANING PROCESS FOR ETCHING SILICON-CONTAINING MATERIAL	January 23, 2003 San Francisco, California

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Box Non-Fee Amendment
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Examiner Olsen:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

Under 37 C.F.R 1.97(c), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the final action or notice of allowance, provided it is accompanied by a certification as specified in Paragraph (e) or a petition fee.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to:

By: *Reece Nienstadt* Assistant Commissioner for Patents
Washington, D.C. 20231
Date: January 23, 2003

Please charge Deposit Account No. 10-0258 in the amount of \$180.00 for payment of the associated petition fee.

The Commissioner is hereby authorized to charge payment of any additional fees associated with this communication and credit any overpayment to Deposit Account No. 10-0258.

It is believed that this disclosure complies with the requirements of 37 C.F.R. §§ 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures § 707.05(b). If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations provided herewith, the undersigned does not know how the translations were made, nor who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

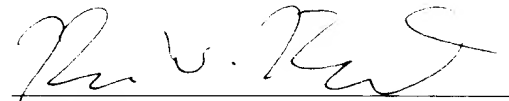
These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Dated: January 23, 2003

By



Reece Nienstadt
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Please direct all telephone calls to:

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Encl.